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PTO/SB/21 (03-03)  
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**TRANSMITTAL  
FORM**

*(to be used for all correspondence after initial filing)*

Application Number	09/234,233
Filing Date	January 20, 1999
First Named Inventor	Weimin Li
Art Unit	2818
Examiner Name	D. Vu
Attorney Docket Number	MI22-1035

Total Number of Pages in This Submission

**ENCLOSURES (Check all that apply)**

- ☐ Fee Transmittal Form
- ☐ Fee Attached
- ☐ Amendment/Reply
- ☐ After Final
- ☐ Affidavits/declaration(s)
- ☐ Extension of Time Request
- ☐ Express Abandonment Request
- ☒ Information Disclosure Statement
- ☐ Certified Copy of Priority Document(s)
- ☐ Response to Missing Parts/Incomplete Application
- ☐ Response to Missing Parts under 37 CFR 1.52 or 1.53

- ☐ Drawing(s)
- ☐ Licensing-related Papers
- ☐ Petition
- ☐ Petition to Convert to a Provisional Application
- ☐ Power of Attorney, Revocation
- ☐ Change of Correspondence Address
- ☐ Terminal Disclaimer
- ☐ Request for Refund
- ☐ CD, Number of CD(s) \_\_\_\_\_

- ☐ After Allowance Communication to a Technology Center (TC)
- ☐ Appeal Communication to Board of Appeals and Interferences
- ☐ Appeal Communication to TC (Appeal Notice, Brief, Reply Brief)
- ☐ Proprietary Information
- ☐ Status Letter
- ☒ Other Enclosure(s) (please identify below):  
PTO-1449  
cited references

**Remarks**

Customer No. 021567  
The Commissioner is hereby authorized to charge any additional fees required under 37 C.F.R. Section 1.16 and Section 1.17 and credit any overpayments to account no. 23-0925.

**SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT**

Firm or Individual	James E. Lake Reg. No. 44,854, Wells St. John P.S.
Signature	
Date	25 Jun 2004

**CERTIFICATE OF TRANSMISSION/MAILING**

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on this date: \_\_\_\_\_

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This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. **SEND TO: Commissioner for Patents, Washington, DC 20231.**

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EV372451881



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. . . . . 09/234,233  
Filing Date . . . . . January 20, 1999  
Inventor . . . . . Weimin Li, et al  
Assignee . . . . . Micron Technology, Inc.  
Group Art Unit . . . . . 2818  
Examiner . . . . . D. Vu  
Attorney's Docket No. . . . . MI22-1035  
Title: Semiconductor Processing Methods

**INFORMATION DISCLOSURE STATEMENT**

References – See Attached Form PTO-1449

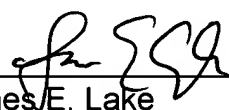
In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed after the filing of a Request for Continued Examination (RCE) Application and prior to the receipt of the first Office Action. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 25 Jun 2004

By:   
James E. Lake  
Reg. No. 44,854

EV372451881

200 Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
MI22-1035SERIAL NO.  
09/234,233LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)APPLICANT  
Weimin LiFILING DATE  
January 20, 1999GROUP  
2818

## U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA 4,971,655	11-90	Stefano et al.			
	AB 6,498,084B2	12-02	Bergemont			
	AC 5,036,383	07-91	Mori			
	AD 6,638,875	10/03	Han et al			
	AE 6,720,247	04/04	Kirkpatrick et al			
	AF 6,723,631	04/04	Noguchi et al			
	AG 6,627,535	09/03	MacNeil et al			
	AH 5,593,741	01/97	Ikeda			
	AI 2003/0077916	04/03	Xu et al			
	AJ 2003/0207594	11/03	Catabay et al			
	AK 2004/0071878	04/04	Schuhmacher et al			

## FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AL 08-045926A	2/96	Japan				
	AM JP8051058	02/96	Japan				
	AN JP63316476	12/88	Japan				
	AO JP8078322	03/96	Japan				

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AP		Wolf, S., Silicon Process., Vol. 3 pg. 635
	AQ		
	AR		

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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